

METHOD FOR FORMING COATING FILM

ABSTRACT

The present invention provides a method for forming a coating film which is excellent in low-temperature curability.

The method of forming a coating film according to an embodiment of the present invention includes coating a substrate with an aqueous coating composition to form a coating film, wherein the aqueous coating composition includes: an aqueous epoxy-based polyamine resin (A) having one or more primary amino groups and/or secondary amino groups in a molecule; and a compound (B) having one or more (meth)acryloyl groups in a molecule.

No Suitable Figure